

International Research Journal of Engineering and Technology (IRJET) e-ISSN: 2395-0056

IRJET Volume: 04 Special Issue: 09 | Sep -2017 www.irj

www.irjet.net

One Day International Seminar on Materials Science & Technology (ISMST 2017) 4<sup>th</sup> August 2017

Organized by

Department of Physics, Mother Teresa Women's University, Kodaikanal, Tamilnadu, India

# Effect of precursor on the efficient formation of ZnS thin films for buffer layer

## G. Genifer Silvena<sup>1</sup>, Bincy John<sup>1</sup>, A. Leo Rajesh<sup>1\*</sup>

<sup>1</sup>Department of Physics, St. Joseph's College, Tiruchirappalli, Tamilnadu, India Corresponding author's e-mail id: aleorajesh@gmail.com \*\*\*\_\_\_\_\_\_

**Abstract** - *ZnS* thin films were found to be a promising replacement for the toxic CdS buffer layers in thin film photovoltaic cells in the recent years. The ZnS thin films were prepared using chemical spray pyrolysis technique with an equimolar ratio of Zn-S precursors. The effect of different precursors Zinc (II) chloride dihydrate, Zinc acetate dihydrate, Zinc Nitrate hexahydrate and Zinc sulphate heptahydrate were taken as precursors for Zinc and thiourea was taken as sulfur source in the preparation of ZnS thin films. The films were deposited at a temperature of 400°C and with a flow rate of 1.5ml/min. The deposited films were characterized using Xray diffraction (XRD), Field Emission Scanning Electron Microscopy (FESEM), UV-Visible spectroscopy and photoluminescence. The XRD pattern confirmed the polycrystalline film formation with the intensed (111) phase. The morphological images showed sphere like shapes of the particles. The UV-Visible spectrum showed maximum transmittance value for a buffer layer and a wide bandgap for the photons to pass through. The optical emission spectrum and purity of the material was analyzed from the photoluminescence study.

# *Key Words*: ZnS, thin films, precursors, spray pyrolysis, buffer layer.

### **1. INTRODUCTION**

ZnS thin films are promising replacements for CdS buffer layers in thin film solar cells. Though CdS layers are suitable and available in application level in efficient photovoltaic cells a requirement for replacement is CdS buffer layers is due to its toxic nature and less transparency [1]. Replacement of 'Zn' in the place of 'Cd' makes it as a toxic free material which is useful for the eco-friendly fabrication of thin film solar cells. ZnS has high transmittance in the Visible and IR region and has an optimum bandgap of  $\sim$  3.7 eV [2].

Various deposition techniques are followed to deposit buffer layers in thin film solar cells. The most common methods among them is spray pyrolysis [3-5] and chemical bath deposition [6] because it is large scale applicable economically and convenient for ambient conditions. Other deposition techniques such as sputtering [7], thermal evaporation [8], pulsed lased deposition [9] and sol-gel [10]. Wide range of investigations is being done on this material such as pH variation, temperature variation and variation in molar ratio, etc.

In the present study ZnS thin films are deposited onto glass substrates with four different Zinc precursor materials and their structural, morphological and optical properties are studied. This work helps in identifying the suitable starting material to deposit ZnS thin films using chemical spray pyrolysis technique.

#### 2. EXPERIMENTAL

ZnS thin films were prepared using aqueous solutions of four precursor materials Zinc Nitrate hexahydrate (Zn  $(NO_3)_2.6H_2O$ ), Zinc (II) chloride dihydrate (ZnCl\_2.2H\_2O), Zinc acetate dihydrate (Zn  $(CH_3COO)_2.2H_2O$ ) and Zinc sulphate heptahydrate (ZnSO\_4.7H\_2O) for Zinc source and Thiourea  $(CH_4N_2S)$  for Sulphur source. The films were deposited using spray pyrolysis technique at a temperature of 400°C, pressure of 1.2 kg/cm<sup>2</sup> and a solution flow rate of 1.5 ml/min. The concentrations were constantly taken at 1:1 molar ratios for Zn and S materials in 40 ml of aqueous solution. The solutions were sprayed continuously onto the cleaned and preheated glass substrates. Four types of films were prepared named as ZnS-1, ZnS-2, ZnS-3 and ZnS-4 in the above precursor order respectively.

The prepared films were characterized using X-ray diffractometer (XPERT-PRO) with a scan range of  $10^{\circ}$  to  $80^{\circ}$  with CuK $\alpha$  radiation to study the structural formation. The surface morphology was studied using FESEM (Carl Zeiss) at 10kV source voltage. The optical properties were studied using UV-Visible spectroscopy (Perkin Elmer Lambda 576) for a wavelength region of 300-1100 nm and Photoluminescence spectrometer (Fluorimeter LS45) with an excitation wavelength of 270 nm.

International Research Journal of Engineering and Technology (IRJET) e-ISSN: 2395-0056

IRJET Volume: 04 Special Issue: 09 | Sep -2017 www.irjet.net

One Day International Seminar on Materials Science & Technology (ISMST 2017) 4<sup>th</sup> August 2017

Organized by

Department of Physics, Mother Teresa Women's University, Kodaikanal, Tamilnadu, India

#### **3. RESLTS AND DISCUSSIONS**

#### **3.1 Structural Analysis**

The crystalline structure of the films is analyzed using XRD which is shown in Fig-1. The deposited films possess polycrystalline nature with cubic crystal structure (JCPDS: 80-0020) and the lattice parameters are of a=b=c=5.345Å [11]. The peak at 28.6° corresponds to (111) plane and the peak at 48.1° corresponds to (220) plane and a minor peak at

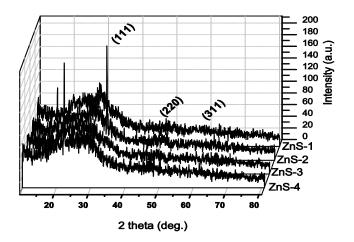


Fig -1: XRD pattern of ZnS-1, ZnS-2, ZnS-3 and Zn-4

 $56.3^{\circ}$  (311) is identified [12]. The intensed peak at  $28.6^{\circ}$  is identified in all the films. The minor peak presence is there in ZnS-1 and trace presence are seen in remaining samples.

#### 3.2 Morphological Analysis

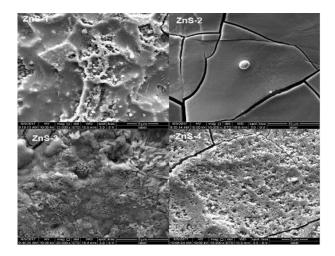


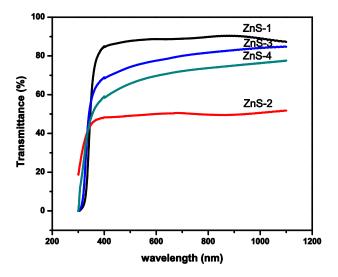
Fig-2: SEM images of ZnS-1, ZnS-2, ZnS-3 and ZnS-4.

The morphological images show sphere like shape of the particles which is seen in Fig -2. The films ZnS-2 and ZnS-4 films contain micro cracks on the surface. The films are having smother and uniform deposition. The films show larger grain growth on the upper surface.

p-ISSN: 2395-0072

#### **3.2 Optical Analyses**

The optical transmittance of the films is shown in Fig -3a. All the films exhibit considerable optical transmittance value with the maximum transmittance value obtained for ZnS-1 film. The ZnS-1 film exhibits high transmittance value of 80% whereas a low transmittance is obtained for ZnS-2 with 50%. The ZnS-3 and ZnS-4 shows 60 and 70% of transmittance values respectively.



**Fig -3a:** Optical transmittance of ZnS-1, ZnS-2, ZnS-3 and Zn-4

The optical bandgap value is calculated from Tauc plot as shown in Fig-3b by plotting hv vs.  $(\alpha hv)^2$  and is found to be 3.54, 3.44, 3.6, 3.36 eV for ZnS-1, ZnS-2, ZnS-3 and ZnS-4 respectively. The optimum bandgap value is obtained for ZnS-3 film of 3.6 eV is useful for buffer layer. [13]

International Research Journal of Engineering and Technology (IRJET) e-ISSN: 2395-0056

IRJET Volume: 04 Special Issue: 09 | Sep -2017 www

www.irjet.net

p-ISSN: 2395-0072

One Day International Seminar on Materials Science & Technology (ISMST 2017) 4<sup>th</sup> August 2017

**Organized by** 

Department of Physics, Mother Teresa Women's University, Kodaikanal, Tamilnadu, India

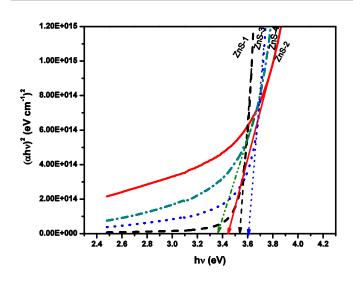


Fig -3b: Optical bandgap of the films

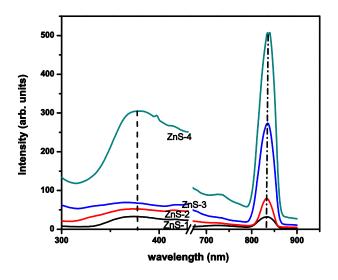


Fig -4: Photoluminescence spectra of the films

The photoluminescence analysis in Fig -4 shows the emission spectrum of the films. It has emission in both smaller and longer wavelength regions. The emission at 377 nm corresponding to 3.3 eV green bands [14-16] corresponds to ZnS phase whereas the higher wavelength emission shows the phosphorescence property. This material possesses both fluorescence and phosphorescence characteristics which emits in both lower and higher wavelength regions.

#### 4. CONCLUSIONS

ZnS thin films were deposited using spray pyrolysis technique with four different precursor sources and their structural, morphological and optical properties were studied. Among those samples ZnS-3 exhibits good crystalline nature and morphological property. It has a wide bandgap of 3.6 eV which is optimum for buffer layer in photovoltaic cell.

#### REFERENCES

- [1] N. Khemiri, F. Aousgi and M. Kanzari, "Tunable optical and structural properties of Zn(S,O) thin films as Cd-free buffer layer in solar cells," Mater. Lett. 2017, doi:10.1016/j.matlet.2017.04.037
- [2] A. Djelloul, M. Adnane, Y. Larbah, T. Sahraoui, C. Zegadi,
  A. Maha and B. Rahal, "Properties Study of ZnS Thin Films Prepared by Spray Pyrolysis Method," J. Nano-Electron. Phys., vol. 7, 2015, pp. 04045-04050
- [3] T. Dedova, M. Krunks, I. Gromyko, V. Mikli, I. Sildos, K. Utt, and T. Unt, "Effect of Zn:S molar ratio in solution on the properties of ZnS thin films and the formation of ZnS nanorods by spray pyrolysis," Phys. Status Solidi A, vol. 211, 2014, pp. 514-521, doi:10.1002/pssa.201300215
- T. Dedova, M. Krunks, O. Volobujeva, and I. Oja, "ZnS thin films deposited by spray pyrolysis technique," phys. stat. sol. (c) vol. 2, 2005, pp. 1161-1166, doi:10.1002/pssc.200460651.
- [5] Srinivasan Thiruvenkadam, D. Jovina and A.LeoRajesh, " The influence of deposition tmperature I the photovoltaic properties of spray deposited CZTS thin films," Sol. Energy, vol.206, 2014, pp.166-170.
- [6] Qi Liua, Mao Guobing and Ao Jianping. "Chemical bathdeposited ZnS thin films: Preparation and characterization," Appl. Surf. Sci., vol. 254, 2008, pp. 5711-5714, doi:10.1016/j.apsusc.2008.03.059
- [7] Dong Hyun Hwang, Jung Hoon Ahn, Kwun Nam Hui, Kwan San Hui and Yong Guk Son, "Stuctural and optical prperties of ZnS thin films deposited by RF magnetron sputtering," Nanoscale Research letters, 2012, doi:10.1186/1556-276X-7-26.
- [8] K.Benyahia, A. Benhaya and M.S. Aida, "ZnS thin films deposition by thermal evaporation for photovoltaic application," J. Semicond. vol.36,2015, pp.103001-4.
- [9] J.K. Chung, W.J. Kim, S.S. Kim, T.K. Song, S.Y. Park, T.K. Lee and C. J. Kim, "The epitaxial growth and optical properties of ZnS thin films deposited by pulsed laser deposition," Phys. Scr., vol. T139, 2010, pp.014018 (1-4).

International Research Journal of Engineering and Technology (IRJET) e-ISSN: 2395-0056

**IRIET** Volume: 04 Special Issue: 09 | Sep -2017

www.irjet.net

p-ISSN: 2395-0072

**One Day International Seminar on Materials Science & Technology (ISMST 2017)** 4<sup>th</sup> August 2017

**Organized by** 

Department of Physics, Mother Teresa Women's University, Kodaikanal, Tamilnadu, India

- [10] S.W. Lu, and H.K. Schmidt, "Photoluminescence and XPS analyses of Mn2+ doped ZnS nanocrystals embedded in Sol-gel derived hybrid coatings, Mat. Res. Bull., vol.43, 2008, pp.583-589.
- [11] Kaifu Qiu, Depeng Qiu, Lun Cai, Shenghao Li, Weiliang Wu, Zongcun Liang and Hui Shen, "Preparation of ZnS thin films and ZnS/p-Si heterojunction solar cells," Materials Letters, 10.1016/j.matlet.2017.03.171.
- [12] H.H. Afifi, S.A. Mahmoud and A. Ashour, "Structural study of ZnS thin films prepared by spray pyrolysis," Thin Solid Films, vol.2.63, 1995, pp. 248-251.
- [13] P.A.Luque, A.Castro-Beltran, A.R.Vilchis-Nestor, M.A.Quevedo-Lopez, "Influence A.Olivas, ofpHonpropertiesofZnSthin films deposited on SiO<sub>2</sub> substrate by chemical bath deposition,t." Mater. Levol.140, 2014, pp.148-150. doi:10.1016/j.matlet.2014.10.167
- [14] T. Ben Nasr, N. Kamoun, M. Kanzari, R. Bennaceur, "Effect of pH on the properties of ZnS thin films grown by chemical bath deposition," Thin Solid Films, vol.500, 2006, pp. 4-8, doi:10.1016/j.tsf.2005.11.030
- [15] R.Jeyachitraa, P. RajasekaraN and V. Senthilnathan, "Optical and photoluminescence studies of vacuum evaporated ZnS thin films," Chalcogenide Letters vol.11, 2014, pp.303-310.
- [16] J.P. Borah and K.C. Sarma, " Optical and Optoelectronic Properties of ZnS Nanostructured Thin Film, "ACTA PHYSICA POLONICA A vol.114, pp. 2008, 713-719.D. Kornack and P. Rakic, "Cell Proliferation without Neurogenesis in Adult Primate Neocortex," Science, vol. 294, Dec. 2001, pp. 2127-2130, doi:10.1126/science.1065467.